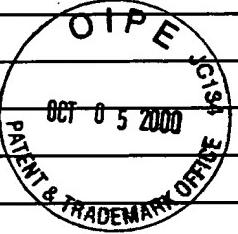
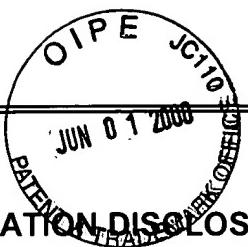


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| Examiner <i>SAP</i> | Date Considered <i>12-07-00</i> | | | | | | |
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| INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | Applicant: Shunpei YAMAZAKI et al. | | | | | |
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